



# CERTIFICATE OF ACCREDITATION

## The ANSI National Accreditation Board

Hereby attests that

**Fox Valley Metrology, Ltd.**  
3114 Medalist Drive  
Oshkosh, WI 54902  
(and satellite locations as shown on the scope)

Fulfills the requirements of

**ISO/IEC 17025:2017**

and national standards

**ANSI/NCSL Z540-1-1994 (R2002) and  
ANSI/NCSL Z540.3-2006 (R2013)**

In the fields of

**CALIBRATION AND DIMENSIONAL MEASUREMENT**

This certificate is valid only when accompanied by a current scope of accreditation document.  
The current scope of accreditation can be verified at [www.anab.org](http://www.anab.org).

R. Douglas Leonard Jr., VP, PILR SBU

Expiry Date: 15 June 2023

Certificate Number: ACT-1272



This laboratory is accredited in accordance with the recognized International Standard ISO/IEC 17025:2017.  
This accreditation demonstrates technical competence for a defined scope and the operation of a laboratory  
quality management system (refer to joint ISO-ILAC-IAF Communiqué dated April 2017).

**SCOPE OF ACCREDITATION TO ISO/IEC 17025:2017,  
ANSI/NCSL Z540-1-1994 (R2002) AND ANSI/NCSL Z540.3-2006 (R2013)**

**Fox Valley Metrology, Ltd.**  
3114 Medalist Drive  
Oshkosh, WI 54902  
Brian Gliszinski 920-426-5894

Services performed at satellite locations as indicated in far-right column  
308 Axminister Drive, Fenton, MO 63026  
30447 Stacy Ponds Drive, Stacy, MN 55079  
5245 27<sup>th</sup> Avenue, Rockford, IL 61109  
305 South Charlotte Avenue, Monroe, NC 28112

**CALIBRATION AND DIMENSIONAL MEASUREMENT**

Valid to: **June 15, 2023**

Certificate Number: **ACT-1272**

**CALIBRATION**

**Acoustics and Vibration**

<b>Parameter/Equipment</b>	<b>Range</b>	<b>Expanded Uncertainty of Measurement (+/-)</b>	<b>Reference Standard, Method, and/or Equipment</b>
Sound Level – Source <sup>1</sup> (100 Hz, 250 Hz, 500 Hz, 1 000 Hz, 2 000 Hz)	114 dB	0.6 dB	Gen Rad 1562-A Sound Level Calibrator  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Accelerometers 1 g reference 1 g reference	10 Hz to 2 kHz (2 to 10) kHz	1.5 % of reading 1.4 % of reading	PCB 9150C Accelerometer Calibration Workstation  Oshkosh, WI

**Chemical Quantities**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
pH Meters <sup>1</sup>	(4.01, 7, 10) pH	0.02 pH	pH Buffer Solutions  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Conductivity Meters <sup>1</sup>	12.85 mS/cm 1408 µS/cm 10 µS/cm	0.18 mS/cm 14 µS/cm 0.18 µS/cm	Conductivity Solutions  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Refractometers <sup>1</sup>	(4.99, 7.52, 10.03, 12.53, 14.98, 30.08) Brix	0.24 Brix	Refractive Index Solutions  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC

**Electrical – DC/Low Frequency**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
DC Voltage – Source <sup>1</sup> (Fixed Value)	10 V	0.8 µV/V	Fluke 732B Voltage Standard  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC

**Electrical – DC/Low Frequency**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
DC Voltage – Source <sup>1</sup>	Up to 220 mV 220 mV to 2.2 V (2.2 to 11) V (11 to 22) V (22 to 220) V (220 to 1 100) V	12 $\mu$ V/V + 0.4 $\mu$ V 5.8 $\mu$ V/V + 0.7 $\mu$ V 4.2 $\mu$ V/V + 2.5 $\mu$ V 4.1 $\mu$ V/V + 4 $\mu$ V 5.8 $\mu$ V/V + 40 $\mu$ V 7.6 $\mu$ V/V + 0.4 mV	Fluke 5720A Multiproduct Calibrator  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
DC Voltage – Measure <sup>1</sup>	Up to 200 mV 200 mV to 2 V (2 to 20) V (20 to 200) V (200 to 1 050) V	5 $\mu$ V/V + 0.1 $\mu$ V 3.5 $\mu$ V/V + 0.4 $\mu$ V 3.5 $\mu$ V/V + 4 $\mu$ V 5.5 $\mu$ V/V + 40 $\mu$ V 5.5 $\mu$ V/V + 0.5 mV	Fluke 8508A 8.5 Digit Multimeter  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
DC High Voltage – Measure <sup>1</sup>	(1 to 10) kV (10 to 100) kV	60 V 600 V	Hipotronics KVM-100 High Voltage Meter  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
DC Current – Source <sup>1</sup>	Up to 220 $\mu$ A 220 $\mu$ A to 2.2 mA (2.2 to 22) mA (22 to 220) mA 220 mV to 2.2 A	0.12 mA/A + 6 nA 42 $\mu$ A/A + 7 nA 41 $\mu$ A/A + 40 nA 52 $\mu$ A/A + 0.7 $\mu$ A 93 $\mu$ A/A + 12 $\mu$ A	Fluke 5720A Multiproduct Calibrator  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
DC Current – Source <sup>1</sup>	(2.2 to 11) A (11 to 20.5) A	0.58 mA/A + 0.5 mA 1.2 mA/A + 0.75 mA	Fluke 5522A Multiproduct Calibrator  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC

**Electrical – DC/Low Frequency**

<b>Parameter/Equipment</b>	<b>Range</b>	<b>Expanded Uncertainty of Measurement (+/-)</b>	<b>Reference Standard, Method, and/or Equipment</b>
DC Current – Source <sup>1</sup>	Up to 100 A	0.008 % of reading + 4 mA	Fluke 52120A Transconductance Amplifier  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
DC Current – Source <sup>1</sup> Clamp-on Meters	Up to 2 500 A	0.6 % of reading	Fluke 52120A Transconductance Amplifier with 25-turn coil  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
DC Current – Measure <sup>1</sup>	Up to 200 $\mu$ A 200 $\mu$ A to 2 mA (2 to 20) mA (20 to 200) mA 200 mA to 2 A (2 to 20) A	12 $\mu$ A/A + 0.4 nA 12 $\mu$ A/A + 4 nA 14 $\mu$ A/A + 40 nA 48 $\mu$ A/A + 0.8 $\mu$ A 0.19 mA/A + 16 $\mu$ A 4 mA/A + 0.4 mA	Fluke 8508A 8.5 Digit Multimeter  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Resistance – Measure <sup>1</sup> (Normal Mode)	Up to 2 $\Omega$ (2 to 20) $\Omega$ (20 to 200) $\Omega$ 200 $\Omega$ to 2 k $\Omega$ (2 to 20) k $\Omega$ (20 to 200) k $\Omega$ 200 k $\Omega$ to 2 M $\Omega$ (2 to 20) M $\Omega$ (20 to 200) M $\Omega$	17 $\mu\Omega/\Omega$ + 4 $\mu\Omega$ 9.5 $\mu\Omega/\Omega$ + 14 $\mu\Omega$ 8 $\mu\Omega/\Omega$ + 50 $\mu\Omega$ 8 $\mu\Omega/\Omega$ + 0.5 m $\Omega$ 8 $\mu\Omega/\Omega$ + 5 m $\Omega$ 8 $\mu\Omega/\Omega$ + 50 m $\Omega$ 9 $\mu\Omega/\Omega$ + 1 $\Omega$ 20 $\mu\Omega/\Omega$ + 0.1 k $\Omega$ 0.12 m $\Omega/\Omega$ + 10 k $\Omega$	Fluke 8508A 8.5 Digit Multimeter  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC

**Electrical – DC/Low Frequency**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Resistance – Measure <sup>1</sup> High Voltage Mode	(2 to 20) MΩ (20 to 200) MΩ 200 mΩ to 2 GΩ (2 to 20) GΩ	17 μΩ/Ω + 10 Ω 65 μΩ/Ω + 1 kΩ 0.18 mΩ/Ω + 0.1 MΩ 15 mΩ/Ω + 10 MΩ	Fluke 8508A 8.5 Digit Multimeter  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Resistance – Source <sup>1</sup> (Simulation-Fixed)	0 Ω 1 Ω 1.9 Ω 10 Ω 19 Ω 100 Ω 190 Ω 1 kΩ 1.9 kΩ 10 kΩ 19 kΩ 100 kΩ 190 kΩ 1 MΩ 1.9 MΩ	0.11 mΩ 0.11 mΩ 0.21 mΩ 0.27 mΩ 0.51 mΩ 1.4 mΩ 2.6 mΩ 11 mΩ 21 mΩ 0.11 Ω 0.21 Ω 1.3 Ω 2.7 Ω 24 Ω 48 Ω	Fluke 5720A Multiproduct Calibrator  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Resistance – Source <sup>1</sup> (Simulation-Fixed)	10 MΩ 19 MΩ 100 MΩ	0.48 kΩ 1.1 kΩ 23 kΩ	Fluke 5720A Multiproduct Calibrator  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Resistance – Source <sup>1</sup> (Artifact-Fixed)	1 GΩ 10 GΩ 100 GΩ	1.9 MΩ 47 MΩ 0.95 GΩ	IET Labs HRRS Decade Box  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC



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Electrical – DC/Low Frequency

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
AC Voltage – Source <sup>1</sup>	Up to 2.2 mV		<p>Fluke 5720A Multiproduct Calibrator</p> <p>Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC</p>
	(10 to 20) Hz	0.24 mV/V + 4 μV	
	(20 to 40) Hz	0.09 mV/V + 4 μV	
	40 Hz to 20 kHz	0.08 mV/V + 4 μV	
	(20 to 50) kHz	0.2 mV/V + 4 μV	
	(50 to 100) kHz	0.5 mV/V + 5 μV	
	(100 to 300) kHz	1.05 mV/V + 10 μV	
	(300 to 500) kHz	1.4 mV/V + 20 μV	
	500 kHz to 1 MHz	2.7 mV/V + 20 μV	
	(2.2 to 22) mV		
	(10 to 20) Hz	0.24 mV/V + 4 μV	
	(20 to 40) Hz	0.09 mV/V + 4 μV	
	40 Hz to 20 kHz	0.08 mV/V + 4 μV	
	(20 to 50) kHz	0.2 mV/V + 4 μV	
	(50 to 100) kHz	0.5 mV/V + 5 μV	
	(100 to 300) kHz	1.05 mV/V + 10 μV	
	(300 to 500) kHz	1.4 mV/V + 20 μV	
	500 kHz to 1 MHz	2.7 mV/V + 20 μV	
	(22 to 220) mV		
	(10 to 20) Hz	0.24 mV/V + 12 μV	
	(20 to 40) Hz	0.09 mV/V + 7 μV	
	40 Hz to 20 kHz	0.08 mV/V + 7 μV	
	(20 to 50) kHz	0.2 mV/V + 7 μV	
	(50 to 100) kHz	0.46 mV/V + 17 μV	
	(100 to 300) kHz	0.9 mV/V + 20 μV	
	(300 to 500) kHz	1.4 mV/V + 25 μV	
	500 kHz to 1 MHz	2.7 mV/V + 45 μV	
	(0.22 to 2.2) V		
(10 to 20) Hz	0.2 mV/V + 40 μV		
(20 to 40) Hz	0.075 mV/V + 15 μV		
40 Hz to 20 kHz	0.025 mV/V + 8 μV		
(20 to 50) kHz	0.055 mV/V + 10 μV		
(50 to 100) kHz	0.080 mV/V + 30 μV		
(100 to 300) kHz	0.23 mV/V + 80 μV		
(300 to 500) kHz	0.7 mV/V + 0.2 mV		
500 kHz to 1 MHz	1 mV/V + 0.3 mV		

**Electrical – DC/Low Frequency**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment	
AC Voltage – Source <sup>1</sup>	(2.2 to 22) V		Fluke 5720A Multiproduct Calibrator  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC	
	(10 to 20) Hz	0.2 mV/V + 0.4 mV		
	(20 to 40) Hz	0.075 mV/V + 0.15 mV		
	40 Hz to 20 kHz	0.025 mV/V + 50 μV		
	(20 to 50) kHz	0.055 mV/V + 0.1 mV		
	(50 to 100) kHz	0.08 mV/V + 0.2 mV		
	(100 to 300) kHz	0.25 mV/V + 0.6 mV		
	(300 to 500) kHz	0.7 mV/V + 2 mV		
	500 kHz to 1 MHz	1.1 mV/V + 3.2 mV		
	(22 to 220) V			
	(10 to 20) Hz	0.24 mV/V + 4 mV		
	(20 to 40) Hz	0.09 mV/V + 1.5 mV		
	40 Hz to 20 kHz	0.052 mV/V + 0.6 mV		
	(20 to 50) kHz	0.08 mV/V + 1 mV		
	(50 to 100) kHz	0.15 mV/V + 2.5 mV		
(100 to 300) kHz	0.9 mV/V + 16 mV			
(300 to 500) kHz	4.4 mV/V + 40 mV			
500 kHz to 1 MHz	8 mV/V + 80 mV			
(220 to 1 100) V				
(15 to 50) Hz	0.3 mV/V + 16 mV			
50 Hz to 1 kHz	0.07 mV/V + 3.5 mV			
AC Voltage – Source <sup>1</sup>	(330 to 1 020) V		Fluke 5522A Multiproduct Calibrator  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC	
	45 Hz to 1 kHz	0.23 mV/V + 10 mV		
	(1 to 5) kHz	0.19 mV/V + 10 mV		
	(5 to 10) kHz	0.23 mV/V + 10 mV		
AC Voltage Harmonics – Source <sup>1</sup>	(2 <sup>nd</sup> to 50 <sup>th</sup> )		Fluke 5522A Multiproduct Calibrator  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC	
	(10 to 45) Hz	32 mV to 33 V		0.35 mV/V + 16 μV
	(45 to 65) Hz	33 mV to 1 000 V		0.21 mV/V + 16 μV
	(65 to 500) Hz	33 mV to 1 000 V		0.21 mV/V + 16 μV
	500 Hz to 5 kHz	330 mV to 1 000 V		0.21 mV/V + 0.21 mV
	(5 to 10) kHz	(3.3 to 1 000) V		0.21 mV/V + 1.2 mV



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Electrical – DC/Low Frequency

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
AC Voltage – Measure <sup>1</sup>	(1 to 10) kV (50 to 60) Hz (10 to 100) kV (50 to 60) Hz	0.12 kV  1.2 kV	Hipotronics KVM-100 High Voltage Meter  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
AC Voltage – Measure <sup>1</sup> Bandwidth < 1 MHz	Up to 200 mV (1 to 10) Hz (10 to 40) Hz (40 to 100) Hz 100 Hz to 2 kHz (2 to 10) kHz (10 to 30) kHz (30 to 100) kHz 200 mV to 2 V (1 to 10) Hz (10 to 40) Hz (40 to 100) Hz 100 Hz to 2 kHz (2 to 10) kHz (10 to 30) kHz (30 to 100) kHz (100 to 300) kHz 300 kHz to 1 MHz (2 to 20) V (1 to 10) Hz (10 to 40) Hz (40 to 100) Hz 100 Hz to 2 kHz (2 to 10) kHz (10 to 30) kHz (30 to 100) kHz (100 to 300) kHz 300 kHz to 1 MHz	0.17 mV/V + 14 μV 0.14 mV/V + 4 μV 0.12 mV/V + 4 μV 0.11 mV/V + 2 μV 0.14 mV/V + 4 μV 0.34 mV/V + 8 μV 0.77 mV/V + 20 μV  0.15 mV/V + 0.12 mV 0.12 mV/V + 20 μV 90 μV/V + 20 μV 75 μV/V + 20 μV 0.11 mV/V + 20 μV 0.22 mV/V + 0.84 mV 0.57 mV/V + 0.2 mV 3 mV/V + 2 mV 10 mV/V + 2 mV  0.15 mV/V + 1.2 mV 0.12 mV/V + 0.2 mV 90 μV/V + 0.2 mV 75 μV/V + 0.2 mV 0.11 mV/V + 0.2 mV 0.22 mV/V + 8.4 mV 0.57 mV/V + 2 mV 3 mV/V + 20 mV 10 mV/V + 20 mV	Fluke 8508A 8.5 Digit Multimeter  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC

**Electrical – DC/Low Frequency**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
AC Voltage – Measure <sup>1</sup> Bandwidth < 1 MHz	(20 to 200) V (1 to 10) Hz (10 to 40) Hz (40 to 100) Hz 100 Hz to 2 kHz (2 to 10) kHz (10 to 30) kHz (30 to 100) kHz (100 to 300) kHz 300 kHz to 1 MHz (200 to 1 050) V (1 to 10) Hz (10 to 40) Hz 40 Hz to 10 kHz (10 to 30) kHz (30 to 100) kHz	0.15 mV/V + 12 mV 0.12 mV/V + 2 mV 90 μV/V + 2 mV 75 μV/V + 2 mV 0.11 mV/V + 2 mV 0.22 mV/V + 84 mV 0.57 mV/V + 20 mV 3 mV/V + 0.2 V 10 mV/V + 0.2 V 0.15 mV/V + 70 mV 0.12 mV/V + 20 mV 0.12 mV/V + 20 mV 0.23 mV/V + 40 mV 0.58 mV/V + 0.2 V	Fluke 8508A 8.5 Digit Multimeter  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
AC Current – Source <sup>1</sup>	Up to 220 μA (10 to 20) Hz (20 to 40) Hz 40 Hz to 1 kHz (1 to 5) kHz (5 to 10) kHz 220 μA to 2.2 mA (10 to 20) Hz (20 to 40) Hz 40 Hz to 1 kHz (1 to 5) kHz (5 to 10) kHz (2.2 to 22) mA (10 to 20) Hz (20 to 40) Hz 40 Hz to 1 kHz (1 to 5) kHz (5 to 10) kHz (22 to 220) mA (10 to 20) Hz (20 to 40) Hz 40 Hz to 1 kHz (1 to 5) kHz (5 to 10) kHz	0.30 mA/A + 16 nA 0.20 mA/A + 10 nA 0.16 mA/A + 8 nA 0.22 mA/A + 12 nA 1.3 mA/A + 65 nA 0.31 mA/A + 40 nA 0.22 mA/A + 35 nA 0.15 mA/A + 35 nA 0.24 mA/A + 0.11 μA 1.3 mA/A + 0.65 μA 0.32 mA/A + 0.4 μA 0.23 mA/A + 0.35 μA 0.15 mA/A + 0.35 μA 0.24 mA/A + 0.55 μA 1.3 mA/A + 5 μA 0.3 mA/A + 4 μA 0.2 mA/A + 3.5 μA 0.15 mA/A + 2.5 μA 0.24 mA/A + 3.5 μA 1.3 mA/A + 10 μA	Fluke 5720A Multiproduct Calibrator  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC

**Electrical – DC/Low Frequency**

<b>Parameter/Equipment</b>	<b>Range</b>	<b>Expanded Uncertainty of Measurement (+/-)</b>	<b>Reference Standard, Method, and/or Equipment</b>
AC Current – Source <sup>1</sup>	220 mA to 2.2 A 20 Hz to 1 kHz (1 to 5) kHz (5 to 10) kHz (2 to 3) A (10 to 45) Hz 40 Hz to 1 kHz (1 to 5) kHz (5 to 10) kHz	0.31 mA/A + 35 μA 0.53 mA/A + 80 μA 8.1 mA/A + 0.16 mA  2.1 mA/A + 0.1 mA 0.75 mA/A + 0.1 mA 6.9 mA/A + 1 mA 29 mA/A + 5 mA	Fluke 5720A Multiproduct Calibrator  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
AC Current – Source <sup>1</sup>	(3 to 11) A (45 to 100) Hz (0.1 to 1) kHz (1 to 5) kHz (11 to 20.5) A (45 to 100) Hz (0.1 to 1) kHz (1 to 5) kHz	0.74 mA/A + 2 mA 1.2 mA/A + 2 mA 35 mA/A + 2 mA  1.4 mA/A + 5 mA 1.8 mA/A + 5 mA 35 mA/A + 5 mA	Fluke 5522A Multiproduct Calibrator  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
AC Current – Source <sup>1</sup>	Up to 50 A (6 to 10) kHz Up to 100 A (3 to 6) kHz Up to 300 A (1 to 3) kHz Up to 1 000 A 300 Hz to 1 kHz Up to 2 500 A (10 to 300) Hz	0.8 % of reading  0.75 % of reading  0.7 % of reading  0.8 % of reading  0.6 % of reading	Fluke 52120A Transconductance Amplifier with 25-turn Coil  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
AC Current – Source <sup>1</sup>	Up to 120 A (10 to 65) Hz (65 to 300) Hz 300 Hz to 1 kHz	0.012 % of reading + 19.2 mA 0.023 % of reading + 27.6 mA 0.078 % of reading + 93.6 mA	Fluke 52120A Transconductance Amplifier  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC

**Electrical – DC/Low Frequency**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
AC Current Harmonics – Source <sup>1</sup> (2 <sup>nd</sup> to 50 <sup>th</sup> ) (10 to 45) Hz (45 to 65) Hz (65 to 500) Hz 500 Hz to 5 kHz (5 to 10) kHz	3.3 mA to 3 A 3.3 mA to 20.5 A 33 mA to 20.5 A 33 mA to 20.5 A (33 to 330) mA	1.1 mA/A + 4 μA 0.5 mA/A + 4 μA 1.2 mA/A + 0.1 mA 2.3 mA/A + 0.2 mA 4.6 mA/A + 0.4 mA	Fluke 5522A Multiproduct Calibrator  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
AC Current – Measure <sup>1</sup>	Up to 200 μA (1 to 10) Hz 10 Hz to 10 kHz (10 to 30) kHz (30 to 100) kHz 200 μA to 2 mA (1 to 10) Hz 10 Hz to 10 kHz (10 to 30) kHz (30 to 100) kHz (2 to 20) mA (1 to 10) Hz 10 Hz to 10 kHz (10 to 30) kHz (30 to 100) kHz (20 to 200) mA (1 to 10) Hz 10 Hz to 10 kHz (10 to 30) kHz 200 mA to 2 A 10 Hz to 2 kHz (2 to 10) kHz (10 to 30) kHz (2 to 20) A 10 Hz to 2 kHz (2 to 10) kHz	0.31 mA/A + 20 nA 0.3 mA/A + 20 nA 0.71 mA/A + 20 nA 4 mA/A + 20 nA  0.31 mA/A + 0.2 μA 0.3 mA/A + 0.2 μA 0.71 mA/A + 0.2 μA 4 mA/A + 0.2 μA  0.31 mA/A + 2 μA 0.3 mA/A + 2 μA 0.71 mA/A + 2 μA 4 mA/A + 2 μA  0.31 mA/A + 20 μA 0.3 mA/A + 20 μA 0.63 mA/A + 20 μA  0.62 mA/A + 0.2 mA 0.73 mA/A + 0.2 mA 3 mA/A + 0.2 mA  0.82 mA/A + 2 mA 2.5 mA/A + 2 mA	Fluke 8508A 8.5 Digit Multimeter  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Capacitance – Measure <sup>1</sup> 42 Hz to 5 MHz	0.32 pF to 370 mF	1.1 mF/F	Hioki 3532-50 LCR Meter  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC

**Electrical – DC/Low Frequency**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Capacitance – Source <sup>1</sup> (Simulation)	130 pF to 3.3 nF (3.3 to 11) nF (11 to 110) nF (110 to 330) nF 330 nF to 1.1 μF (1.1 to 3.3) μF (3.3 to 11) μF (11 to 33) μF (33 to 110) μF (110 to 330) μF 330 μF to 1.1 mF (1.1 to 3.3) mF (3.3 to 11) mF (11 to 33) mF (33 to 110) mF	5.8 mF/F + 10 pF 2.9 mF/F + 10 pF 2.9 mF/F + 0.1 nF 2.9 mF/F + 0.3 nF 2.9 mF/F + 1 nF 2.9 mF/F + 3 nF 2.9 mF/F + 10 nF 4.7 mF/F + 30 nF 5.3 mF/F + 0.1 μF 1 mF/F + 0.3 μF 6 mF/F + 1 μF 5.3 mF/F + 3 μF 5.3 mF/F + 10 μF 8.9 mF/F + 30 μF 13 mF/F + 0.1 mF	Fluke 5522A Multiproduct Calibrator  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Phase – Measure <sup>1</sup>	Up to 360 ° 10 Hz to 2 kHz (2 to 5) kHz (5 to 10) kHz (10 to 50) kHz (50 to 60) kHz (60 to 70) kHz (70 to 80) kHz (80 to 90) kHz (90 to 100) kHz (100 to 500) kHz 500 kHz to 1 MHz	0.026 ° 0.036 ° 0.048 ° 0.059 ° 0.07 ° 0.082 ° 0.093 ° 0.1 ° 0.12 ° 0.58 ° 1.2 °	Clark Hess 6000A Phase Meter  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
DC Power – Source <sup>1</sup>	10 mW to 330 W 330 W to 3 kW (3 to 20.5) kW	0.27 mW/W 0.26 mW/W 0.82 mW/W	Fluke 5522A Multiproduct Calibrator  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC

**Electrical – DC/Low Frequency**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
AC Power – Source <sup>1</sup>	100 $\mu$ W to 9 W (9 to 33) W (33 to 90) W (90 to 330) W (330 to 900) W 900 W to 2.2 kW	1.7 mW/W 1.2 mW/W 1.7 mW/W 1.2 mW/W 11 mW/W 4.6 mW/W	Fluke 5522A Multiproduct Calibrator  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Oscilloscopes <sup>1</sup>			
DC Voltage (50 $\Omega$ )	1 mV to 6.6 V	2.9 mV/V + 40 $\mu$ V	Fluke 5522A SC1100 Multiproduct Calibrator  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
DC Voltage (1 M $\Omega$ )	1 mV to 130 V	0.55 mV/V + 40 $\mu$ V	
AC Voltage (50 $\Omega$ )	1 mVp-p to 6.6 Vp-p	2.9 mV/V + 40 $\mu$ V	
AC Voltage (1 M $\Omega$ )	1 mVp-p to 130 Vp-p	1.1 mV/V + 40 $\mu$ V	
Leveled Sine Wave 50 kHz to 1.1 GHz	5 mVp-p to 5.5 Vp-p	51 mV/V + 0.1 mV	
Time Markers	1 ns to 5 s	6.4 $\mu$ s/s	
Wave Generator (50 $\Omega$ )	1.8 mVp-p to 2.5 Vp-p	35 mV/V + 0.1 mV	
Wave Generator (1 M $\Omega$ )	1.8 mVp-p to 55 Vp-p	35 mV/V + 0.1 mV	
Pulse Generator – Width	(4 to 45) ns (45 to 500) ns	58 ms/s + 0.5 ns 58 ms/s + 4 ns	
Pulse Generator – Period	200 ns to 20 ms	58 ms/s + 0.2 $\mu$ s	
Input Impedance Measure	(50 to 60) $\Omega$ 500 k $\Omega$ to 1 M $\Omega$	1.2 m $\Omega$ / $\Omega$ 1.2 m $\Omega$ / $\Omega$	

**Electrical – DC/Low Frequency**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Electrical Simulation of RTD Indicating Devices <sup>1</sup>	Pt 385, 100 Ω		<p style="text-align: center;">Fluke 5522A Multiproduct Calibrator</p> <p style="text-align: center;">Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC</p>
	(-200 to -80) °C	0.05 °C	
	(-80 to 0) °C	0.05 °C	
	(0 to 100) °C	0.07 °C	
	(100 to 300) °C	0.09 °C	
	(300 to 400) °C	0.1 °C	
	(500 to 630) °C	0.12 °C	
	(630 to 800) °C	0.23 °C	
	Pt 3926, 100 Ω		
	(-200 to -80) °C	0.05 °C	
	(-80 to 0) °C	0.05 °C	
	(0 to 100) °C	0.07 °C	
	(100 to 300) °C	0.09 °C	
	(300 to 400) °C	0.1 °C	
	(500 to 630) °C	0.12 °C	
	Pt 3916 (JIS), 100 Ω		
	(-200 to -190) °C	0.25 °C	
	(-190 to -80) °C	0.04 °C	
	(-80 to 0) °C	0.05 °C	
	(100 to 260) °C	0.06 °C	
	(260 to 300) °C	0.07 °C	
	(300 to 400) °C	0.09 °C	
	(400 to 600) °C	0.1 °C	
	(600 to 630) °C	0.23 °C	
	Pt 385, 200 Ω		
	(-200 to -80) °C	0.04 °C	
	(-80 to 0) °C	0.04 °C	
	(0 to 100) °C	0.04 °C	
(100 to 260) °C	0.05 °C		
(260 to 300) °C	0.12 °C		
(300 to 400) °C	0.13 °C		
(400 to 600) °C	0.14 °C		
(600 to 630) °C	0.16 °C		

**Electrical – DC/Low Frequency**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Electrical Simulation of RTD Indicating Devices <sup>1</sup>	Pt 385, 500 Ω		Fluke 5522A Multiproduct Calibrator  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
	(-200 to -80) °C	0.04 °C	
	(-80 to 0) °C	0.05 °C	
	(0 to 100) °C	0.05 °C	
	(100 to 260) °C	0.06 °C	
	(260 to 300) °C	0.08 °C	
	(300 to 400) °C	0.08 °C	
	(400 to 600) °C	0.09 °C	
	(600 to 630) °C	0.11 °C	
	Pt 385, 1 000 Ω		
	(-200 to -80) °C	0.03 °C	
	(-80 to 0) °C	0.03 °C	
	(0 to 100) °C	0.04 °C	
	(100 to 260) °C	0.05 °C	
	(260 to 300) °C	0.06 °C	
	(300 to 400) °C	0.07 °C	
	(400 to 600) °C	0.07 °C	
	(600 to 630) °C	0.23 °C	
PtNi 385, 120 Ω, Ni 120			
(-80 to 0) °C	0.08 °C		
(0 to 100) °C	0.08 °C		
(100 to 260) °C	0.14 °C		
Cu 427, 10 Ω			
(-100 to 260) °C	0.03 °C		
Electrical Simulation of Thermocouple Indicating Devices – Source/Measure <sup>1</sup>	Type K		Fluke 5522A Multiproduct Calibrator  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
	(-200 to -100) °C	0.33 °C	
	(-100 to -25) °C	0.18 °C	
	(-25 to 120) °C	0.16 °C	
	(120 to 1 000) °C	0.26 °C	
	(1 000 to 1 372) °C	0.4 °C	
	Type J		
	(-210 to -100) °C	0.27 °C	
	(-100 to -30) °C	0.16 °C	
	(-30 to 150) °C	0.14 °C	
	(150 to 760) °C	0.17 °C	
	(760 to 1 200) °C	0.23 °C	
	Type E		
	(-250 to -100) °C	0.5 °C	
	(-100 to -35) °C	0.16 °C	
	(-25 to 350) °C	0.14 °C	
	(350 to 650) °C	0.16 °C	
	(650 to 1 000) °C	0.21 °C	

**Electrical – DC/Low Frequency**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Electrical Simulation of Thermocouple Indicating Devices – Source/Measure <sup>1</sup>	Type T		Fluke 5522A Multiproduct Calibrator  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
	(-250 to -150) °C	0.63 °C	
	(-150 to 0) °C	0.24 °C	
	(0 to 120) °C	0.16 °C	
	(120 to 400) °C	0.14 °C	
	Type S		
	(0 to 250) °C	0.47 °C	
	(250 to 1 000) °C	0.36 °C	
	(1 000 to 1400) °C	0.37 °C	
	(1 400 to 1 767) °C	0.46 °C	
	Type B		
	(600 to 800) °C	0.44 °C	
	(-100 to -25) °C	0.34 °C	
	(-25 to 120) °C	0.3 °C	
	(120 to 1 000) °C	0.33 °C	
	Type C		
	(0 to 150) °C	0.3 °C	
	(150 to 650) °C	0.26 °C	
	(650 to 1 000) °C	0.31 °C	
	(1 000 to 1 800) °C	0.5 °C	
	(1 800 to 2 316) °C	0.84 °C	
	Type L		
	(-200 to -100) °C	0.37 °C	
	(-100 to 800) °C	0.26 °C	
(800 to 900) °C	0.17 °C		
Type N			
(-200 to -100) °C	0.4 °C		
(-100 to -25) °C	0.22 °C		
(-25 to 120) °C	0.19 °C		
(120 to 410) °C	0.18 °C		
(410 to 1 300) °C	0.27 °C		
Type R			
(0 to 250) °C	0.57 °C		
(250 to 400) °C	0.35 °C		
(400 to 1 000) °C	0.33 °C		
(1 000 to 1767) °C	0.4 °C		
Type U			
(-200 to 0) °C	0.56 °C		
(0 to 600) °C	0.27 °C		

**Electrical – DC/Low Frequency**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Inductance – Source <sup>1</sup> (Artifact-Variable)	(1 to 10) mH (10 to 100) mH 100 mH to 1 H (1 to 10) H	22 mH/H 11 mH/H 6 mH/H 3 mH/H	General Radio 1490-D Decade Inductor  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Ionizers <sup>1</sup> Decay Time Float Voltage	(0.1 to 999.9) s (-1 100 to 1 100) V	0.2 s 3.1 V	Trek 156A Charged Plate Monitor  Oshkosh, WI
ESD Simulators Rise Time Burst/Surge Peak Current 30 ns Current 60 ns Current RC Time Constant	700 ps to 1 ns (7.5 to 30) A (4 to 16) A (2 to 8) A 600 ns 300 ns	0.14 ns 50 mA/A 0.1 A/A 0.12 A/A 20 ns 15 ns	Tektronix TDS684B Oscilloscope with EM Test CTR2 ESD Target IEC 61000-4-2, SAE J1113-13  Oshkosh, WI

**Electrical – RF/Microwave**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
RF Power – Measure <sup>1,4</sup> Absolute Level 100 kHz to 3 GHz (3 to 18) GHz (18 to 26.5) GHz  100 kHz to 3 GHz (3 to 18) GHz (18 to 26.5) GHz	(+20 to +30) dBm     (-20 to +20) dBm	0.37 dB 0.39 dB 0.4 dB  0.15 dB 0.18 dB 0.21 dB	Agilent N5531S Measuring Receiver with N5532A Sensor Modules  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC

**Electrical – RF/Microwave**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Relative Level (3.05 to 6.6) GHz	(-90 to +30) dBm (-113 to -90) dBm	0.026 dB + 0.005 dB/10 dB 0.067 dB + 0.12 dB/10 dB	Agilent N5531S Measuring Receiver with N5532A Sensor Modules
(6.6 to 13.2) GHz	(-81 to +30) dBm (-104 to -81) dBm	0.026 dB + 0.005 dB/10 dB 0.062 dB + 0.12 dB/10 dB	Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
(13.2 to 19.2) GHz	(-70 to +30) dBm (-93 to -70) dBm	0.026 dB + 0.005 dB/10 dB 0.056 dB + 0.12 dB/10 dB	Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Relative Level (19.2 to 26.5) GHz	(-62 to +30) dBm (-85 to -62) dBm	0.026 dB + 0.005 dB/10 dB 0.051 dB + 0.12 dB/10 dB	Agilent N5531S Measuring Receiver with N5532A Sensor Modules  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Amplitude Modulation – Source <sup>1,4</sup> Rate: DC to 100 kHz Depths: 0 % to 100 %	250 kHz to 40 GHz	7.1 % of reading	Agilent E8257D Signal Generator  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Amplitude Modulation – Measure <sup>1,4</sup>			
100 kHz to 10 MHz	Rate: 50 Hz to 10 kHz Depths: 5 % to 99 %	2.2 % of reading	Agilent N5531S Measuring Receiver with N5532A Sensor Modules  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
10 MHz to 3 GHz	Rate: 50 Hz to 100 kHz Depths: 20 % to 99 %	1.2 % of reading	
10 MHz to 3 GHz	Rate: 50 Hz to 100 kHz Depths: 5 % to 20 %	4.2 % of reading	
(3 to 26.5) GHz	Rate: 50 Hz to 100 kHz Depths: 20 % to 99 %	3.5 % of reading	
(3 to 26.5) GHz	Rate: 50 Hz to 100 kHz Depths: 5 % to 20 %	6 % of reading	



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**Electrical – RF/Microwave**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Phase Modulation – Source <sup>1,4</sup> Rate: DC to 100 kHz	250 kHz to 40 GHz	5.9 % of reading + 0.1 rad	Agilent E8257D Signal Generator  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Tuned RF Level – Measure <sup>1,4</sup> Absolute Level 500 kHz to 3.05 GHz	(+16 to +30) dBm (-106 to +16) dBm (-129 to -106) dBm	0.37 dB + 0.005 dB/10 dB 0.15 dB + 0.005 dB/10 dB 0.15 dB + 0.12 dB/10 dB	Agilent N5531S Measuring Receiver with N5532A Sensor Modules
(3.05 to 6.6) GHz	(+20 to +30) dBm (-90 to +20) dBm (-114 to -90) dBm	0.39 dB + 0.005 dB/10 dB 0.18 dB + 0.005 dB/10 dB 0.23 dB + 0.12 dB/10 dB	Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
(6.6 to 13.2) GHz	(+20 to +30) dBm (-81 to +20) dBm (-104 to -81) dBm	0.39 dB + 0.005 dB/10 dB 0.18 dB + 0.005 dB/10 dB 0.23 dB + 0.12 dB/10 dB	
Tuned RF Level – Measure <sup>1,4</sup> Absolute Level (13.2 to 19.2) GHz	(+20 to +30) dBm (-70 to +20) dBm (-93 to -70) dBm	0.4 dB + 0.005 dB/10 dB 0.21 dB + 0.005 dB/10 dB 0.25 dB + 0.12 dB/10 dB	Agilent N5531S Measuring Receiver with N5532A Sensor Modules
(19.2 to 26.5) GHz	(+20 to +30) dBm (-62 to +20) dBm (-85 to -62) dBm	0.4 dB + 0.005 dB/10 dB 0.21 dB + 0.005 dB/10 dB 0.24 dB + 0.12 dB/10 dB	Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
500 kHz to 3.05 GHz	(-90 to +30) dBm (-106 to -90) dBm (-129 to -106) dBm	0.026 dB + 0.005 dB/10 dB 0.067 dB + 0.12 dB/10 dB 0.076 dB + 0.12 dB/10 dB	

**Electrical – RF/Microwave**

<b>Parameter/Equipment</b>	<b>Range</b>	<b>Expanded Uncertainty of Measurement (+/-)</b>	<b>Reference Standard, Method, and/or Equipment</b>
RF Power – Source <sup>1</sup> 250 kHz to 2 GHz (2 to 20) GHz (20 to 40) GHz	> -10 dBm	0.72 dB 0.96 dB 1.1 dB	Agilent E8257D Signal Generator
250 kHz to 2 GHz (2 to 20) GHz (20 to 40) GHz	(-10 to -70) dBm	0.89 dB 1.1 dB 1.2 dB	Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
250 kHz to 2 GHz (2 to 20) GHz (20 to 40) GHz	(-70 to -90) dBm	0.95 dB 1.2 dB 1.21 dB	
RF Power Sensors – Calibration Factor <sup>1,4</sup> 100 kHz to 10 MHz 10 MHz to 10 GHz (10 to 18) GHz	(-20 to +14) dBm (-20 to +14) dBm (-20 to +14) dBm	1.5 % of reading 1.5 % of reading 1.7 % of reading	Tegam 1827 Power Sensor Calibrator, Agilent 3458 <sup>a</sup> Multimeter, Agilent E8257D Signal Generator, Agilent E4419B Power Meter, Agilent 3325B Function Generator  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Frequency Modulation – Measure <sup>1,4</sup> 250 kHz to 10 MHz	Rate: 20 Hz to 10 kHz Dev.: ≤ 40 kHz peak	3.1 % of reading	Agilent N5531S Measuring Receiver with N5532A Sensor Modules
10 MHz to 3 GHz	Rate: 20 Hz to 200 kHz Dev.: ≤ 400 kHz peak	3.1 % of reading	Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
(3 to 26.5) GHz	Rate: 20 Hz to 200 kHz Dev.: ≤ 400 kHz peak	7.7 % of reading	

**Electrical – RF/Microwave**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Frequency Modulation – Source <sup>1,4</sup> 250 kHz to 40 GHz	1 dB Rate: DC to 100 kHz 3 dB Rate: DC to 10 MHz Dev: $\leq (N \times 800 \text{ kHz})$	4.2 % of reading + 20 Hz	Agilent E8257D Signal Generator  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Pulse Generation – Measure <sup>1,4</sup> DC to 225 MHz Pulse Width Rise/Fall Time	5 ns to 1 000 000 s 5 ns to 1 000 000 s	1.1 ns 1.1 ns	Agilent 53132A Counter  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Pulse Generation – Source <sup>1,4</sup> Repetition Frequency: 0.024 Hz to 14.28 MHz Period: 70 ns to 42 s	10 ns to 42 s	1.7 ns	Agilent E8257D Signal Generator  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC

**Length – Dimensional Metrology**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Gage Blocks <sup>2</sup>	Up to 30 in	$(3.8 + 0.93L) \mu\text{in}$	Mahr 828 Measuring Machine, Per ASME B89.1.9  Oshkosh, WI

**Length – Dimensional Metrology**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Gage Blocks <sup>2</sup>	Up to 20 in	$(8.5 + 1L) \mu\text{in}$	ULM 600 Measuring Machine, Per ASME B89.1.9  Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Length Standards <sup>2</sup>	Up to 39 in	$(12 + 1L) \mu\text{in}$	Mahr 828 Measuring Machine, Per ASME B89.1.1  Oshkosh, WI
Length Standards <sup>2</sup>	(39 to 70) in	$(390 + 2.6L) \mu\text{in}$	CMM  Oshkosh, WI Stacy, MN
Cylindrical Rings <sup>2</sup>	(0.025 to 18) in	$(8 + 1.8D) \mu\text{in}$	Mahr 828 Measuring Machine, ASME B89.1.6  Oshkosh, WI
Cylindrical Rings <sup>1,2</sup>	(0.25 to 8) in	$(12 + 3D) \mu\text{in}$	Fowler Lab Concept Measuring Machine, ASME B89.1.6  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Cylindrical Plugs <sup>2</sup>	(0.010 to 30) in	$(2.7 + 6D) \mu\text{in}$	Mahr 828 Measuring Machine  Oshkosh, WI

**Length – Dimensional Metrology**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Cylindrical Plugs <sup>1,2</sup>	(0.010 to 4) in	$(53 + 0.4D) \mu\text{in}$	Plug Gage Comparator  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Thread Rings <sup>2</sup> Pitch Diameter  Pitch Diameter  Minor Diameter	Up to Setting plug size Up to 16 in  Up to 14 in  Up to 9 in	$(240 + 0.3D) \mu\text{in}$  38 $\mu\text{in}$  120 $\mu\text{in}$	Setting Plug Gages, ULM 600 Measuring Machine, ID Bore Gages, ASME B1.2  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
NPT Rings (Standoff and Basic Length)	(0.0625 to 8) in	250 $\mu\text{in}$	NPT Plugs, P&W LabMaster, ASME B1.20.5  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
NPT Plugs (Standoff and Basic Length)	(0.0625 to 6) in	490 $\mu\text{in}$	NPT Rings, P&W LabMaster, ASME B1.20.5  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC

**Length – Dimensional Metrology**

<b>Parameter/Equipment</b>	<b>Range</b>	<b>Expanded Uncertainty of Measurement (+/-)</b>	<b>Reference Standard, Method, and/or Equipment</b>
Thread Plugs <sup>2</sup> Pitch Diameter Major Diameter	Up to 24 in Up to 24 in	$(73 + 0.9D) \mu\text{in}$ $(40 + 1.2D) \mu\text{in}$	P&W Supermicrometer, Thread Measuring Wires, ASME B1.2  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Thread Plugs <sup>1,2</sup> Pitch Diameter Major Diameter	Up to 4 in Up to 4 in	$(73 + 3.2D) \mu\text{in}$ $(53 + 4.1D) \mu\text{in}$	Plug Gage Comparator  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Thread Wires <sup>2</sup>	Up to 0.5 in	$(11 + 1.5D) \mu\text{in}$	ULM 600 Measuring Machine, ASME B89.1.17  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Calipers <sup>1,2</sup>	Up to 80 in	$(380 + 15L) \mu\text{in}$	Gage Blocks  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Indicators <sup>1,2</sup>	Up to 4 in	$(36 + 10L) \mu\text{in}$	Indicator Checker  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC

**Length – Dimensional Metrology**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Test Indicators <sup>1</sup>	Up to 0.06 in	39 μin	Indicator Checker  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
OD Micrometers <sup>1,2</sup>	Up to 60 in	(72 + 12L) μin	Gage Blocks  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
ID Micrometer <sup>1,2</sup>	(1.5 to 40) in	(370 + 7L) μin	Gage Blocks  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Height Gages <sup>1,2</sup>	Up to 40 in	(96 + 14L) μin	Gage Blocks  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Bore Gages <sup>1</sup>	(0.25 to 12) in	45 μin	Cylindrical Rings  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC

**Length – Dimensional Metrology**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Crimpers <sup>1</sup> Die Check Crimp Height	(0.011 to 0.5) in (0.01 to 0.5) in	230 μin 0.001 2 in	Pin Gages, Micrometer Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Profilometers <sup>1</sup>	(2 to 300) μin Ra	2.2 μin	Roughness Specimen Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Profilometer Reference Specimens	(0.01 to 300) μin Ra	2.1 μin	Profilometer Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Surface Plates <sup>1,2</sup>			
Repeat Reading	(4 to 34) inDL	35 μin	In accordance to with ASME B89.3.7 using Repeat-O-Meter
Overall Flatness	(34 to 175) inDL	(92 + 0.14DL) μin	Electronic Levels Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC

**Length – Dimensional Metrology**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
CMM Calibration <sup>1,2</sup> Volumetric  Linearity	(5 to 40) in  (1 to 60) in > 60 in	(12 + 14L) μin  (7 + 14L) μin (20 + 0.4L) μin	Ball Bars, Step Gage, Renishaw Laser System, B89.4.1  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Linear Measurements	Up to 1 560 in	(38 + 0.5L) μin	Renishaw Laser System  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Optical Comparators <sup>1,2</sup> Linearity  Magnification	Up to 12 in  10x, 20x, 31.25x, 50x, 62.5x, 100x, 200x	(97 + 12L) μin  460 μin	Glass Scale, Precision Balls, Calibration Sphere  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Roundness Testers <sup>1</sup> Axial Error  Radial Error	(-1 000 to 1 000) μm  (-1 000 to 1 000) μm	0.15 μm  0.15 μm	Test Sphere  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
ULMs <sup>1</sup> (Length)	(1 to 100) mm	0.19 μm	Gage Blocks  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC

**Length – Dimensional Metrology**

<b>Parameter/Equipment</b>	<b>Range</b>	<b>Expanded Uncertainty of Measurement (+/-)</b>	<b>Reference Standard, Method, and/or Equipment</b>
Thickness Gages <sup>1</sup>	Up to 0.06 in Up to 6 in	380 μin 380 μin	Film Thickness Standards Gage Blocks  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Brinell Scopes <sup>1</sup>	(1 to 6) mm	11 μm	Stage Micrometer  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC

**Mass and Mass Related**

<b>Parameter/Equipment</b>	<b>Range</b>	<b>Expanded Uncertainty of Measurement (+/-)</b>	<b>Reference Standard, Method, and/or Equipment</b>
Bench and Floor Scales <sup>1,5</sup>	Up to 5 000 lb	0.000 7 lb/lb	NIST 105 Class F Weights and NIST Handbook 44 utilized in the calibration of the weighing system.  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC

**Mass and Mass Related**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Analytical Balances <sup>1,5</sup>	Up to 6 kg	0.19 µg/g	ASTM E617 Class 1 Weights and NIST Handbook 44 utilized in the calibration of the weighing system.  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Mass – Avoirdupois	100 lb 50 lb 25 lb 20 lb 10 lb 5 lb 2 lb 1 lb 0.5 lb 8 oz 4 oz 2 oz 1 oz 0.5 oz 0.25 oz 0.125 oz 0.0625 oz 0.03125 oz	0.77 g 0.65 g 0.46 g 0.37 g 0.12 g 0.11 g 84 mg 73 mg 24 mg 23 mg 22 mg 21 mg 21 mg 0.44 mg 0.26 mg 0.19 mg 0.17 mg 0.13 mg	Class 1 Weights and Analytical Balance, Modified Substitution  Oshkosh, WI Fenton, MO (Class F Only) Stacy, MN (Class F Only)

**Mass and Mass Related**

<b>Parameter/Equipment</b>	<b>Range</b>	<b>Expanded Uncertainty of Measurement (+/-)</b>	<b>Reference Standard, Method, and/or Equipment</b>
Mass – Metric	5 000 g	46 mg	Class 1 Weights and Analytical Balance, Modified Substitution  Oshkosh, WI Fenton, MO (Class F Only) Stacy, MN (Class F Only)
	3 000 g	30 mg	
	2 000 g	23 mg	
	1 000 g	18 mg	
	500 g	16 mg	
	300 g	16 mg	
	200 g	1.8 mg	
	100 g	0.9 mg	
	50 g	0.47 mg	
	30 g	0.32 mg	
	20 g	0.19 mg	
	10 g	0.11 mg	
	5 g	61 µg	
	3 g	45 µg	
	2 g	36 µg	
1 g	26 µg		
Mass – Metric	500 mg	20 µg	Class 1 Weights and Analytical Balance, Modified Substitution  Oshkosh, WI Fenton, MO (Class F Only) Stacy, MN (Class F Only)
	300 mg	18 µg	
	200 mg	15 µg	
	100 mg	13 µg	
	50 mg	11 µg	
	30 mg	9.5 µg	
	20 mg	9.1 µg	
	10 mg	8.0 µg	
	5 mg	7.5 µg	
	3 mg	7.1 µg	
	2 mg	6.8 µg	
	1 mg	6.7 µg	
Pressure <sup>1</sup>	(-1 to 1) inWc	0.1 % of reading + 0.000 2 inWc	Setra MicroCal Pressure Calibrator  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
	(-5 to 5) inWc	0.12 % of reading + 0.001 4 inWc	

**Mass and Mass Related**

<b>Parameter/Equipment</b>	<b>Range</b>	<b>Expanded Uncertainty of Measurement (+/-)</b>	<b>Reference Standard, Method, and/or Equipment</b>
Absolute Pressure	(0.2 to 500) psia	0.013 % of reading	Ruska 2465 Deadweight Tester  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Gauge Pressure	(3 000 to 40 000) psig	0.2 % of reading	Budenberg BGH2600 Deadweight Tester  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Durometers <sup>1</sup> Spring Force	Up to 100 duro Up to 45 N	0.35 duro 0.05 N	Direct Verification per ASTM D2240 Durometer Calibrator, Triple Beam Balance
Indenter Angle	(20 to 40) °	0.07 °	Video Measuring Machine
Indenter Radius	Up to 0.1 in	340 μin	Video Measuring Machine
Indenter Length	Up to 0.198 in	330 μin	Gage Blocks  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC

**Mass and Mass Related**

<b>Parameter/Equipment</b>	<b>Range</b>	<b>Expanded Uncertainty of Measurement (+/-)</b>	<b>Reference Standard, Method, and/or Equipment</b>
Brinell Hardness Testers <sup>1</sup>  Verification of Test Force  Verification of Indenter Mean Diameter	(500, 750, 1 500, 2 000, 3 000) kgf  10 mm 5 mm	7.2 kgf  0.002 mm 0.002 mm	Direct Verification per ASTM E10 using Morehouse Proving Ring  Video Measuring Machine  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Brinell Hardness Testers <sup>1</sup>	(1 to 7) mm	0.03 mm	Indirect Verification per ASTM E10 using Brinell Test Blocks and Brinell Scope  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Knoop and Vickers Hardness Testers <sup>1</sup>	(1 to 200) $\mu$ m  (1 to 200) $\mu$ m	0.25 $\mu$ m  0.17 $\mu$ m	Indirect Verification per ASTM E384 using Knoop and Vickers Test Blocks  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Leeb Hardness Tester <sup>1</sup>	(300 to 900) LD	20 LD	Indirect Verification per ASTM A596 using Leeb Test Blocks  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC

**Mass and Mass Related**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Rockwell Hardness Testers <sup>1</sup>	HRBW Low	1.4 HRBW	Indirect Verification per ASTM E18 using Rockwell Test Blocks  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
	HRBW Med	1.4 HRBW	
	HRBW High	1.3 HRBW	
	HRA Low	1.2 HRA	
	HRA Med	1.2 HRA	
	HRA High	0.75 HRA	
	HRC Low	1.2 HRC	
	HRC Med	1.2 HRC	
	HRC High	0.7 HRC	
	HRE Low	1.3 HRE	
	HRE Med	1.4 HRE	
	HRE High	1.4 HRE	
	HRF Low	1.4 HRF	
	HRF Med	1.4 HRF	
	HRF High	1.4 HRF	
	HRH Low	1.4 HRH	
	HRH Med	1.4 HRH	
	HRH High	1.4 HRH	
	HRKW Low	1.4 HRKW	
	HRKW Med	1.3 HRKW	
	HRKW High	1.3 HRKW	
	HRMW Low	1.4 HRMW	
	HRMW Med	1.4 HRMW	
	HRMW High	1.3 HRMW	
HR15N Low	1.5 HR15N		
HR15N Med	1.3 HR15N		
HR15N High	0.9 HR15N		
HR30N Low	1.3 HR30N		
HR30N Med	1.3 HR30N		
HR30N High	0.9 HR30N		



ANSI National Accreditation Board

Mass and Mass Related

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Rockwell Hardness Testers <sup>1</sup>	HR45N Low HR45N Med HR45N High  HR15TW Low HR15TW Med HR15TW High  HR30TW Low HR30TW Med HR30T High  HR45TW Low HR45TW Med HR45TW High	1.4 HR45N 1.3 HR45N 0.95 HR45N  2 HR15TW 1.4 HR15TW 1.5 HR15TW  2 HR30TW 1.5 HR30TW 1.3 HR30TW  2 HR45TW 1.3 HR45TW 1.4 HR45TW	Indirect Verification per ASTM E18 using Rockwell Test Blocks  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Force <sup>1</sup>	Up to 100 lb  Up to 500 lb (500 to 2 000) lb (2 000 to 12 500) lb (12 500 to 50 000) lb (50 000 to 500 000) lb	0.05 % of reading  0.05 % of reading 0.07 % of reading 0.1 % of reading 0.1 % of reading 0.1 % of reading	Dead Weight  Load Cells  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Force	Up to 200 lb  Up to 1 000 lb (1 000 to 10 000) lb (10 000 to 100 000) lb	0.05 % reading  0.03 % reading 0.03 % reading 0.04 % reading	Dead Weight  Load Cells  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Wedge Tester <sup>1</sup>	Up to 40 000 N	32 N	Load Cell  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC

**Mass and Mass Related**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Torque Transducers <sup>1</sup>	(Up to 250) lbf-ft (250 to 2 000) lbf-ft	0.05 % of reading 0.06 % of reading	Torque Arms, Dead Weight  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Torque Tools <sup>1</sup>	(10 to 200) ozf-in 4 lbf-in to 2 000 lbf-ft	0.5 % of reading 0.3 % of reading	CDI Torque System  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Viscosity Rotational Viscometers	500 cP 5 000 cP	0.02 cP/cP	Viscosity Solutions, Temperature Bath  Oshkosh, WI Stacy, MN
Viscosity Cups	17.82 cP 65.28 cP 231 cP	0.03 cP/cP	Viscosity Solutions, Temperature Bath, Stopwatch Per ASTM D4212  Oshkosh, WI Stacy, MN
Pipettes	Up to 20 µL (20 to 200) µL (200 to 1 000) µL (1 000 to 5 000) µL (5 000 to 10 000) µL	0.064 µL 0.6 µL 1.8 µL 8.9 µL 18 µL	Analytical Balance Per ISO 8655-6  Oshkosh, WI
Liquid Volume Measuring Devices	Up to 200 mL (200 to 6 000) mL (6 000 to 34 000) mL	0.003 mL 0.46 mL 2.8 mL	Balances  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC

**Mass and Mass Related**

<b>Parameter/Equipment</b>	<b>Range</b>	<b>Expanded Uncertainty of Measurement (+/-)</b>	<b>Reference Standard, Method, and/or Equipment</b>
Foundry Sand Test Equipment / Measurement <sup>1</sup> Ultrasonic Cleaner/Scrubber	18 °F 30 m	1.7 °F 1.2 s	Temperature Calibrator Stopwatch
Wet Tensile Tester	0.449 N/cm <sup>2</sup> (300 to 320) °F	0.003 1 N/cm <sup>2</sup> 2 °F	Dead Weight Temperature Calibrator
Sand Squeezer	Up to 200 psi	3.8 psi	Proving Ring
Tensile Testers	Up to 10 000 lb	7.2 lb	Load Cell
			Oshkosh, WI
Foundry Sand Test Equipment / Measurement <sup>1</sup> AFS Clay Tester	Up to 10 min	1.2 s	Stopwatch
Friability Tester	60 s	1.2 s	Stopwatch
Sand Rammer	Up to 2 in	0.01 in	Impact Rings
Moisture Teller	(0 to 300 °F)	1.9 °F	Temperature Calibrator
Permmeter	Up to 500 perm	0.43 perm	Perm Standards
Sand Strength Tester	Up to 500 psi Up to 1 000 lb	1.1 psi 4.2 lb	Proving Ring
Core Scratch Tester	Up to 0.1 in	0.006 in	Flatness Block
Green Sand Hardness Tester (B&C)	Up to 0.1 in	0.006 in	Flatness Block
			Oshkosh, WI

**Photometry and Radiometry**

<b>Parameter/Equipment</b>	<b>Range</b>	<b>Expanded Uncertainty of Measurement (+/-)</b>	<b>Reference Standard, Method, and/or Equipment</b>
Optical Power – Measure <sup>1</sup> (800 to 1 650) nm	(-70 to +20) dBm	0.03 dB/dBm	Agilent 81533B Interface, 81525A Optical Head  Oshkosh, WI Fenton, MO Stacy, MN
Optical Power – Source <sup>1</sup> (820, 1 310, 1 550) nm	(-60 to 0) dB	0.05 dB/dB	Agilent 81554SM Laser Source Module, 81533B Interface, 81525A Optical Head, 81655A Laser Module, 81570A Optical Attenuator, 81578A Optical Attenuator  Oshkosh, WI Fenton, MO Stacy, MN
Optical Attenuation – Source <sup>1</sup> (700 to 1 650) nm	(-60 to 0) dB	0.04 dB/dB	Agilent 81570A and 81578A Optical Attenuators  Oshkosh, WI Fenton, MO Stacy, MN
Optical Wavelength – Measure <sup>1</sup>	(700 to 1 650) nm	0.05 nm	Agilent 86120B Multi-Wavelength Meter  Oshkosh, WI Fenton, MO Stacy, MN
Gloss Meters <sup>2</sup> 20°, 60°, 85°	(0 to 100) GU	0.73 GU	Standard Gloss Tiles  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC

**Thermodynamic**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Temperature – Source	(-95 to 600) °C (600 to 1200) °C	0.03 °C 2.3 °C	Fluke 9011, 9190A Drywell, PRT, Type S Probe  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Infrared Thermometers <sup>1</sup>	(122 to 932) °F	2.2 °F	Hart Scientific 9132 Blackbody $\lambda = (8 \text{ to } 14) \mu\text{m}$ , $\epsilon = 0.95$  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Surface Probes <sup>1</sup>	(35 to 400) °C	1.3 °C	Hart Scientific 2200 Temperature Controller, Hot-plate  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Temperature – Measure <sup>1</sup>	(-30 to 600) °C (600 to 1200) °C	0.03 °C 1.7 °C	Hart Scientific 1502 Indicator, PRT, Type S Probe  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC

**Thermodynamic**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Thermo-Hygrometers Temperature  Humidity	(0 to 70) °C  (10 to 98) %RH	0.2 °C  0.9 %RH	Thunder Scientific 2500 Humidity Chamber  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
System Accuracy Test <sup>1</sup> (SAT)	(0 to 2 200) °F	2.6 °F	Certified Thermocouple  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Temperature Uniformity Survey (TUS) <sup>1</sup>	(0 to 2 200) °F	4.9 °F	MV 1000 Data Logger or Equivalent  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC

**Time and Frequency**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Time Interval <sup>1</sup>	(1 to 86 400) s	450 μs	Agilent 53132A Counter and Spectracom 8197B GPS Oscillator  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC

**Time and Frequency**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Frequency – Measure <sup>1</sup>	0.1 Hz to 26.5 GHz	7.6 % of reading	Agilent N5531S Measuring Receiver, Spectracom 8197B GPS Oscillator  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Frequency – Source <sup>1</sup>	10 MHz	24 pHz	Spectracom 8197B GPS Oscillator  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Frequency – Source <sup>1</sup>	0.1 mHz to 40 GHz	4.1 % of reading	Agilent 3325B Function Generator, Agilent E8257D Signal Generator, SRS FS725 Frequency Standard  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC
Tachometers <sup>1</sup> Contact  Non-Contact	(1 to 6 500) rpm  (500 to 40 000) rpm	0.08 % of reading  0.08 % of reading	King Nutronics 3711-B Tachometer Test Set  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC

**Time and Frequency**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Tachometers <sup>1</sup> Non-Contact	(0.01 to 100 000) rpm	0.005 % of reading	Fluke 5522A Multiproduct Calibrator  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC

**DIMENSIONAL MEASUREMENT**

**2 Dimensional**

Specific Tests and / or Properties Measured	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method and/or Equipment
Linear	Up to 24 in	0.000 9 in	Video Measuring Machine  Oshkosh, WI Fenton, MO Stacy, MN
Surface Finish (Ra)	(0.01 to 300) $\mu$ in	2.1 $\mu$ in	Profilometer  Oshkosh, WI Fenton, MO Stacy, MN Rockford, IL Monroe, NC

**3 Dimensional**

Specific Tests and / or Properties Measured	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method and/or Equipment
Dimensional Inspection Volumetric	Up to (28 x 40 x 24) in	320 $\mu$ in	Coordinate Measuring Machine
Linear	Up to (28 x 40 x 24) in	(38 + 5.2L) $\mu$ in	Oshkosh, WI Stacy, MN

**3 Dimensional**

Specific Tests and / or Properties Measured	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method and/or Equipment
Angular	Up to 180 °	0.002 5 °	Starrett AVR300  Oshkosh, WI Fenton, MO Stacy, MN

Calibration and Measurement Capability (CMC) is expressed in terms of the measurement parameter, measurement range, expanded uncertainty of measurement and reference standard, method, and/or equipment. The expanded uncertainty of measurement is expressed as the standard uncertainty of the measurement multiplied by a coverage factor of 2 ( $k=2$ ), corresponding to a confidence level of approximately 95%.

Notes:

1. On-site calibration service is available for this parameter, since on-site conditions are typically more variable than those in the laboratory, larger measurement uncertainties are expected on-site than what is reported on the accredited scope.
2.  $L$  = Length in inches,  $D$  = diameter in inches,  $DL$  = diagonal length in inches, GU = Gloss Unit.
3. Where ranges overlap, the uncertainty associated with the higher range begins above the overlapping value.
4. RF/Microwave uncertainties do not include inaccuracies due to sensor mismatch.
5. The CMC for scales and balances is highly dependent upon the resolution of the unit under test. The CMC presented here does not include the resolution of the unit under test. The resolution will be included in the reported measurement uncertainty at the time of calibration.
6. This scope is formatted as part of a single document including Certificate of Accreditation No. ACT-1272.



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